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EFS Transmission Sheet

February 27, 2007

To: **Examiner Lin, James**
From: Stephen P. Burr/Nicole Buckner
Re: In re the Application of: Takao OHNISHI, Masahiro MURASATO, Yuki BESSHOU and Nobuo TAKAHASHI

Serial No : **10/630,887** Art Unit: **1762**

Date Filed: July 30, 2003 Conf. No. **7943**

Title: MANUFACTURING METHOD OF PIEZOELECTRIC/ELECTROSTRRICTIVE FILM TYPE DEVICE

Our Docket No.: **791_204 NP**

I hereby certify that the following 12 page(s) including this cover is/are being transmitted via EFS to the Patent and Trademark Office on **February 27, 2007**:

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Gina M. Husak